

IN THE SPECIFICATION

Please replace the title of the application appearing at page 1, line 1, with the following rewritten title:

METHOD OF FORMING SEMICONDUCTOR DEVICE CAPACITOR BOTTOM
ELECTRODE HAVING CYLINDRICAL SHAPE OF CAPACITOR OF
~~SEMICONDUCTOR DEVICE AND METHOD OF FORMING THE SAME~~

IN THE ABSTRACT

Please replace the title of the application appearing at page 26, line 1, with the following rewritten title:

METHOD OF FORMING SEMICONDUCTOR DEVICE CAPACITOR BOTTOM
ELECTRODE HAVING CYLINDRICAL SHAPE OF CAPACITOR OF
~~SEMICONDUCTOR DEVICE AND METHOD OF FORMING THE SAME~~